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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Wang, et al.

Serial No.: 09/842, 476

Confirmation No.: 7917

Filed: April 25, 2001

For: Chemical Mechanical Polishing  
Composition and Process§  
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Group Art Unit: 1765

Examiner: Lynette Umez-Eronini

MAIL STOP NON-FEE AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING  
37 CFR 1.8I hereby certify that this correspondence is being deposited on  
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Commissioner for Patents, P.O. Box 1450, Alexandria, VA  
22313-1450.11/24/2003  
DateB. E. E.  
Signature

## RESPONSE TO OFFICE ACTION DATED AUGUST 25, 2003

In response to the Office Action dated August 25, 2003, having a shortened statutory period for response set to expire on November 25, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5083/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks/Arguments** begin on page 7 of this paper.